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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Complete if Known						
			Applicati n Number	\$10/602,910					
			Filing Date	June 24, 2003					
			First Named Inventor	SHUICHI TAKAYAMA ET AL.					
			Group Art Unit	1744					
			Examiner Name	Unknown					
Sheet	Sheet 2 of 3		Attorney Docket Number	UOM 0272 PUSP					
	OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS								
Examiner : item (book, magazine, journal, s			CAPITAL LETTERS), title of the arrerial, symposium, catalog, etc.), datalisher, city and/or country where put	ticle (when appropriate), title of the e, page(s), volume-issue number(s), bilshed.	T*				
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Examiner	10	01,	Dat	1/28/06	
Signature		W.1 ~	Considered	1 11 -1-6	

*EXAMINER: Initial if reterence considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.